Supporting Information

Human Hair Keratin for Physically Transient Resistive Switching Memory Devices

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Figure S1. FTIR peak resolution of Amide III band spectra regions (1230-1330 cm⁻¹).



Figure S2. Top-view SEM image of the keratin thin films under low magnification.



Figure S3. (a) Cross-section layered electronic image of the memory structure. (b)-(f) Crosssectional mapping images of the Ag/Keratin/FTO memory device after the electrical measurements. (g) Energy dispersive spectra of the Ag/Keratin/FTO memory device.



Figure S4. Typical I-V curves of the electroforming process of the Ag/Keratin/FTO memory device.



Figure S5. R-V loops at room temperatures of the Ag/Keratin/FTO memory device.



Figure S6. I-V curves of 20 successive switching cycles obtained after 2 month.



Figure S7. Digital photographs illustrating the time sequence of dissolution of the keratin thin films in DI water at room temperature.